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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Ravi Iyer

Serial No.: 09/059,865

Filed: April 14, 1998

For: PLANARIZATION USING PLASMA
OXIDIZED AMORPHOUS SILICON

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Group Art Unit: 2813

Examiner: Nguyen, T.

Atty. Docket: MICS:0015--2/FLE
93-118.02

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

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37 C.F.R. 1.8

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November 10, 2003
Date

John M. Rariden
John M. Rariden

Sir:

AMENDMENT

In response to the Official Action mailed on July 9, 2003, please amend the above-identified application as follows:

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